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Impact of strain on electronic defects in (Mg,Zn)O thin films

Florian Schmidt,a) Stefan Müller, Holger von Wenckstern, Gabriele Benndorf, Rainer Pickenhain, and Marius Grundmann

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We have investigated the impact of strain on the incorporation and the properties of extended and point defects in (Mg,Zn)O thin films by means of photoluminescence, X-ray diffraction, deep-level transient spectroscopy (DLTS), and deep-level optical spectroscopy. The recombination line Y2, previously detected in ZnO thin films grown on an Al-doped ZnO buffer layer and attributed to tensile strain, was exclusively found in (Mg,Zn)O samples being under tensile strain and is absent in relaxed or compressively strained thin films. Furthermore a structural defect E3′ can be detected via DLTS measurements and is only incorporated in tensile strained samples. Finally it is shown that the omnipresent deep-level E3 in ZnO can only be optically recharged in relaxed ZnO samples.

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I. INTRODUCTION

Wide bandgap semiconductors have gained importance and have become technologically relevant in applications such as blue light emitting diodes, UV photo-detectors, high power devices or transparent electronics. Besides the well established nitrides,1,2 oxides like indium oxide, tin oxide3–5 or zinc oxide6,7 (ZnO) triggered research on transparent conducting oxides as new field of material science. In recent years the semiconducting properties of such oxides were exploited, however, the difficulties concerning p-type doping have restricted research to unipolar devices, especially transistors to be utilized in transparent electronics.8,9 Concerning transistors, heterostructures enable fabrication of high-electron mobility transistors but also for the study of confinement effects in quantum wells (QWs) heterostructures are essential. For the case of ZnO magnesium is commonly used for bandgap engineering and realization of QWs. Piezoelectric polarization induced by the strain within the heterostructure modifies recombination properties.10 Further, strain is often accommodated by the incorporation of extended defects. Polarization-induced changes of recombination properties of QWs is not an issue for non-polar samples11–16 however, strain-induced defects are also of importance for such layers. It was shown before that strain influences the recombination properties of ZnO thin films.17 In this contribution, we investigate the impact of in-plane strain on (i) the incorporation of extended defects in (Mg,Zn)O and (ii) the modification of defect properties.

II. SAMPLES

(Mg,Zn)O thin films having a thickness of approximately 1 μm were grown by pulsed-laser deposition (PLD) on 10 × 10 mm2 a-plane and r-plane sapphire substrates, respectively. For that a growth temperature of approximately 650 °C and an oxygen pressure of 0.016 mbar were used. A detailed description of the PLD growth setup can be found in Ref. 18. The respective ceramic MgO/ZnO targets used for sample growth have admixtures of no, 0.10 wt. %, 0.25 wt. %, 1.00 wt. %, and 2.00 wt. % MgO. The Mg-content in the thin films was estimated via low temperature photoluminescence (PL) by evaluating the bandgap shift determined in Ref. 20 and summarized in Table I. Prior to the ZnO layer, an about 200 nm thick aluminium doped (1 wt. %) ZnO (AZO) layer was deposited, which serves as ohmic back-contact and leads to low series resistance of the Schottky diode.21 The high Al-content within this functional layer leads to an increase of the a- and a decrease of the c-lattice compared to nominally undoped ZnO.22,23 A schematic picture of the structure is shown in Fig. 3(b). Schottky contacts were realized by reactive dc-sputtering of PdO, with a subsequent capping with metallic palladium.24 All samples were mounted on sockets having a hole in their center in order to facilitate the illumination from the backside of the structure.

III. RECOMBINATION

PL measurements have been carried out in a helium-bath cryostat at T = 2 K. The samples were excited with an excitation density of about 2 W/cm2 using the 325 nm line of a He-Cd laser. The sample luminescence was spectrally dispersed by a monochromator with a focal length of

<table>
<thead>
<tr>
<th>Target composition</th>
<th>E_L (eV)</th>
<th>Film composition</th>
</tr>
</thead>
<tbody>
<tr>
<td>0.00%</td>
<td>3.3596</td>
<td>0.0%</td>
</tr>
<tr>
<td>0.10%</td>
<td>3.363</td>
<td>0.2%</td>
</tr>
<tr>
<td>0.25%</td>
<td>3.369</td>
<td>0.5%</td>
</tr>
<tr>
<td>0.50%</td>
<td>3.375</td>
<td>0.8%</td>
</tr>
<tr>
<td>1.00%</td>
<td>3.404</td>
<td>2.2%</td>
</tr>
<tr>
<td>2.00%</td>
<td>3.450</td>
<td>4.6%</td>
</tr>
</tbody>
</table>

a)Electronic mail: fschmidt@physik.uni-leipzig.de
\( f = 320 \text{ mm} \) using a 2400 grooves/mm grating and detected by a Peltier-cooled GaAs photomultiplier.

For \((\text{Mg,Zn})\text{O}\) the binary end components, ZnO and MgO, have a wurtzite and a rocksalt crystal structure, respectively. The \(\text{Mg}_x\text{Zn}_{1-x}\text{O}\) alloy displays a transition from one structure to the other at a concentrations of \(0.5 < x < 0.6\). Empirically, for the wurtzite phase of the alloy the \(c\)-lattice constant decreases while the \(a\)-lattice constant increases with respect to binary ZnO. The volume of the wurtzite phase \(\propto a^2\) depends very little on the Mg concentration and thus gives reason to the antagonistic behavior with \(\partial c/\partial x \approx -2\partial a/\partial x\). The change of the binding length of the an- and cation leads to a change in the size of the band gap, which then depends on the composition. Alloying ZnO by MgO will increase the fundamental bandgap compared to binary ZnO.\(^{28,29}\) The Mg-content was estimated via Eq. (1) from Ref. 20 by using the energetic position of the \(I_6\)-line

\[
E_{I_6} = 3.3601(7) \text{ eV} + 1.96(2) \text{ eV} \times x. \tag{1}
\]

For the current study the alloying of ZnO with MgO allows to tune the strain state of polar \((\text{Mg,Zn})\text{O}\) thin films on the ZnO:Al buffer layer. For binary ZnO and for low Mg-contents the polar thin films are expected to be under tensile in-plane strain.\(^{22,23}\) But if the Mg-content is increased more and more there will be a critical Mg concentration \(x_c\) for which the AZO buffer and the \((\text{Mg,Zn})\text{O}\) thin film have similar \(a\)-lattice constant. If the Mg-content is increased above \(x_c\) the \((\text{Mg,Zn})\text{O}\) layers grow relaxed. In Fig. 1, we have compiled the PL data such that the energy scale starts at the transition energy of the \(I_6\) defect or in other words, the energy scale is shifted such that the \(I_6\) transition lies at \(E = 0 \text{ eV}\) for each Mg-content. This is done in order to allow direct comparison of PL features of the investigated samples. In this representation, it is easily seen that the \(Y_0\)-line is present in all samples.\(^{19}\) In an alloy, the random distribution of atoms causes a significant inhomogeneous broadening effect of luminescence lines, which is called \textit{alloy broadening}.\(^{30-32}\) In particular, for \((\text{Mg,Zn})\text{O}\) system alloy broadening has been discussed in Refs. 33–35. Therefore, the full-width at half maximum (FWHM) increases for higher Mg-contents. For the sample with highest Mg-content the \(Y_0\)-line is due to alloy broadening hardly visible. Further, on the energy scale chosen it red-shifts for higher Mg-content due to the increasing band-gap with increasing Mg-content. The structural defect-bound excitonic recombination \(Y_2\) (Ref. 36) is not present for the samples with a Mg-content of \(x \geq 0.8\%). Brandt \textit{et al.} recently showed that this line is connected to tensile strain in ZnO layers.\(^{17}\) From the representation chosen in Fig. 1, it is evident that it is not the alloy broadening that hinders the resolution of this peak; this feature is absent for the three samples with highest Mg-content. For the samples with a Mg-content of \(x \leq 0.5\%\) and, of course, for binary ZnO the \(Y_2\)-line is clearly visible. Relying on the fact that the appearance of the \(Y_2\)-line is connected to tensile strain in the layer and recalling that here the in-plane \(a\)-lattice constant increases in \((\text{Mg,Zn})\text{O}\) with increasing Mg-content we argue that the binary ZnO layer and the layers with a Mg-content up to 0.5% are under tensile strain. For Mg-contents of 0.8% and higher the in-plane \(a\)-lattice constant of the \((\text{Mg,Zn})\text{O}\)-layer is greater or equal to that of the ZnO:Al buffer layer. Please note, that Brandt \textit{et al.} changed the buffer layer in order to change the strain state of the sample. In case of the ternary \((\text{Mg,Zn})\text{O}\) thin films, we however control the lattice constant of the thin film itself by changing the Mg-content. In both cases tensile strain introduces an extended defect traceable by the occurrence of the \(Y_2\) excitonic recombination.\(^{36}\)

Low temperature photoluminescence measurements of binary polar \((c\text{-ZnO})\) and non-polar \((a\text{-ZnO})\) ZnO thin films are depicted in Fig. 1 as well. While the luminescence feature \(Y_0\) is visible independent of the growth direction, \(Y_2\) does not occur for the non-polar thin film but is quite prominent for the polar ZnO sample as mentioned before.

IV. STRUCTURAL PROPERTIES

The lattice constants were obtained by means of X-ray diffraction (XRD) using a PANalytical X’Pert Pro diffractometer. Figure 2(a) depicts the wide angle XRD scans of all thin film samples. Substrate peaks occurring at angles of 37.8° and 80.8° correspond to the (11.0) and (22.0) planes of the \(a\)-plane sapphire and at 25.7°, 52.6°, and 83.4° correspond to the (01.2), (02.4), and (03.6) planes of the \(r\)-plane sapphire, respectively. The peaks visible at 34.4° and 72.6° are the (00.2) and (00.4) reflections of the \(c\)-oriented \((\text{Mg,Zn})\text{O}\) samples, respectively. The reflex of the (11.0)
plane of the non-polar ZnO thin film occurs at 56.5°. The positions of the (00.2)- and (10.1)-reflexes were evaluated by fitting the data assuming Voigt profiles. The 2θ-ω scans are shown in Fig. 2, in which the fitted curves are shown as red solid lines, respectively. The calculated lattice constants are summarized in Table II.

Thin films grown on a-plane sapphire substrates are c-oriented with their a-lattice constants lying parallel and their c-lattice constants lying perpendicular to the c-oriented AZO buffer layer. The (Mg,Zn)O films were grown on an AZO buffer layer, the (00.2)-peak of such a layer is shown for comparison in Fig. 2(b) as a grey line and yields a c-axis lattice parameter of 5.2096 Å. The (10.1)-reflex is rather broad leading to a high inaccuracy in the a-lattice constant, which amounts to 3.2481 Å.

For the polar c-oriented (Mg,Zn)O films the lineshape of the XRD peaks is asymmetric and reveals 3 contributions for the (00.2)-peaks and 2 underlying signals for the (10.1)-reflexes. The broad tail of the (00.2)-peak at lower angles is due to the AZO buffer layer, which is in accordance with the XRD measurement of the 200 nm thick AZO reference sample (grey line in Fig. 2(b)). This back-contact layer is also visible at higher 2θ-angles for the (10.1)-peaks, respectively. Furthermore, all (00.2)-peaks of the polar samples show a shoulder at lower angles. The corresponding XRD-peak is labelled with “A,” the main part of the signal with “B” in Fig. 2(b). Since lower angles in the (00.2)-scan correspond to higher c-lattice constants, part A of the signal is related to a region A of the sample, which is more influenced by the underlying AZO buffer layer, as depicted in Fig. 3(c). Due to, e.g., dislocations the strain is reduced in the (larger) region B, which is responsible for the lion’s share of the XRD signal. This is the region probed by PL and by the space charge spectroscopic methods deep-level transient spectroscopy (DLTS) and deep-level optical spectroscopy (DLOS), shown in Secs. V and VI. The increase of the Mg-content in (Mg,Zn)O leads to an decrease of the c-lattice constant while the a-lattice constant increases.

In Fig. 3(a) the a- and c-lattice constants for all (Mg,Zn)O samples are compared. The open symbols represent lattice constants obtained from region A of the sample, while the solid marks show the corresponding constants obtained from region B (cmp. Fig. 3(b)). The a-lattice constant of the 200 nm thick AZO layer is higher compared to that of binary ZnO (Ref. 23) leading to tensile strain in those films. An increase of the Mg-content x reduces the tensile strain until the films grow unstrained on the AZO buffer, a further increase of x leads to relaxation of the thin films. From Fig. 3(b) a change in the strain state can be expected between 0.5% < x < 0.8%. Remarkably the samples with 0.0% < x < 0.5% and x ≥ 2.2%, i.e., before and after this transition, show the same slope in a over c, which is indicated by the dashed line in Fig. 3(b).

The situation is different in the a-oriented non-polar ZnO thin film, where the c-lattice and one a-lattice constant (aL) are lying in the (11.0)-plane, as shown in Fig. 3(d). The in-plane lattice constants are calculated from the positions of the (00.2)- (c) and (11.0)-reflex (aL), respectively. The out-of-plane a-lattice constant (aL) was obtained via the position of the (10.0)-peak. The in-plane c-lattice constant is smaller than the bulk value indicating uniaxial in-plane compressive strain, which is also manifested in the blue-shift of the I6 transition by 1 meV (not shown). Therefore, the out-of-plane aL-lattice constant is higher than the bulk value in order to maintain the unit cell volume, as illustrated in Fig. 3(d), where the wire frame model depicts the dimension of the polar ZnO thin film.

The observed values for the in- and out-of-plane lattice constants and the associated strain of the films are confirmed...
by the results obtained from the PL experiments, here the \(Y_2\)-line is absent in samples which are not under tensile strain.

V. DEEP DEFECTS

Prior to the DLTS studies the net doping density \(N_{\text{net}}\) was determined from capacitance-voltage measurements (CV) conducted at room temperature using an Agilent 4294 A capacitance bridge. Therefore, a probing frequency of 1 MHz was used. \(N_{\text{net}}\) lies in the range of \(10^{17}\) cm\(^{-3}\), the corresponding values are listed in Table III.

Defects with electronic states in the upper third of the ZnO band gap were studied by DLTS in the temperature range from 10 K to 330 K using a helium flow cryostat. A ZnO band gap were studied by DLTS in the temperature range of 2.5 Hz to 1000 Hz were applied. The DLTS scans are shown in Fig. 4 for the incorporated deep levels. Rate windows in the range of 1 MHz was applied.

The measurements reveal peaks corresponding to deep-levels \(T_1, E_64, T_2, E_4\) in the vicinity of that of \(E_3\). In a conventional DLTS scan the signal-to-noise ratio is observed in the (Mg,Zn)O sample with \(x \leq 0.5\%,\) the signals of these defects lie below the detection limit in samples with \(x \geq 0.8\%). The E3 concentration, on the other hand, tends to increase with increasing Mg-content in latter samples. Since there is no dependence of the net-doping density on \(x\), no change of the Fermi-level position is supposed. Therefore, we conclude that \(T_1, E_64, T_2, E_4\) are actually not incorporated in these samples. A notable decrease of the signal-to-noise ratio is observed in the (Mg,Zn)O sample with \(x = 0.8\%\).

By using high-resolution Laplace-DLTS\(^{69,70}\) (LDLTS), Auret et al. revealed that a defect labeled E3\(^\prime\) exists in as-grown ZnO thin films on AZO buffer causing a DLTS signal in the vicinity of that of E3\(^\prime\). In a conventional DLTS scan E3\(^\prime\) usually occurs only as a shoulder on the high temperature side of the E3 peak for higher rate-windows the signals

### TABLE II. Lattice constants and FWHM (\(\Delta\omega_{\text{FWHM}}\)) values of the \(a\)-oriented (Mg,Zn)O and \(c\)-oriented ZnO thin films obtained from XRD scans. The corresponding region “A” and “B” are shown in Fig. 3(b), respectively. The FWHM was obtained from rocking-curves of the (00.2)-reflex for the polar \(c\)-oriented (Mg,Zn)O films and of the (11.0)-reflex for the \(a\)-oriented ZnO sample.

<table>
<thead>
<tr>
<th>Material</th>
<th>Mg-content (%)</th>
<th>(a_a) (Å)</th>
<th>(a_b) (Å)</th>
<th>(b_b) (Å)</th>
<th>(\Delta\omega_{\text{FWHM}}) (°)</th>
</tr>
</thead>
<tbody>
<tr>
<td>(c)-ZnO:Al (AZO)</td>
<td>–</td>
<td>3.248(12)</td>
<td>5.2096(15)</td>
<td>–</td>
<td>–</td>
</tr>
<tr>
<td>(c)-ZnO</td>
<td>0.0</td>
<td>3.246(2)</td>
<td>3.246(2)</td>
<td>3.246(2)</td>
<td>3.246(2)</td>
</tr>
<tr>
<td>(c)-(Mg,Zn)O</td>
<td>0.2</td>
<td>3.246(7)</td>
<td>3.246(7)</td>
<td>3.246(7)</td>
<td>3.246(7)</td>
</tr>
<tr>
<td>(c)-(Mg,Zn)O</td>
<td>0.5</td>
<td>3.246(9)</td>
<td>3.246(9)</td>
<td>3.246(9)</td>
<td>3.246(9)</td>
</tr>
<tr>
<td>(c)-(Mg,Zn)O</td>
<td>0.8</td>
<td>3.251(5)</td>
<td>3.251(5)</td>
<td>3.251(5)</td>
<td>3.251(5)</td>
</tr>
<tr>
<td>(c)-(Mg,Zn)O</td>
<td>2.2</td>
<td>3.253(2)</td>
<td>3.253(2)</td>
<td>3.253(2)</td>
<td>3.253(2)</td>
</tr>
<tr>
<td>(c)-(Mg,Zn)O</td>
<td>4.6</td>
<td>3.254(7)</td>
<td>3.254(7)</td>
<td>3.254(7)</td>
<td>3.254(7)</td>
</tr>
<tr>
<td>(a)-ZnO</td>
<td>–</td>
<td>((a_a)) 3.2439(130)</td>
<td>5.1904(447)</td>
<td>–</td>
<td>–</td>
</tr>
</tbody>
</table>

FIG. 3. (a) \(a\)- and \(c\)-lattice constants of the \(c\)-(Mg,Zn)O thin films and an AZO buffer reference obtained from XRD scans as shown in Fig. 2. Open (solid) symbols represent the lattice constants streaming from region A (region B), as illustrated in (b). (b) Schematic depiction of the sample-structure investigated with a thin film layer consisting of two regions A and B, and an underlying highly conducting AZO buffer layer. (c) and (d) illustration of an unit-cell of \(c\)- and \(a\)-oriented ZnO, respectively. The wire frame model in (d) represents the dimension of the \(c\)-ZnO unit cell shown in (c).
A low-rate DLTS (LR-DLTS) setup\textsuperscript{68} was used in order to extend the applicable rate-windows to the mHz regime. For such rate-windows the DLTS peaks of E3 and E3' are shifted to lower temperatures at which the emission rate of E3 and E3', respectively, and with that the DLTS signals are easily distinguishable. On the basis of the LR-DLTS data an Arrhenius plot can be constructed.

2. High-resolution LDLTS\textsuperscript{69,70} was applied for all samples of this study, as described in the following.

In Fig. 5, LDLTS spectra calculated from isothermal capacitance transients recorded at $T = 180$ K are shown. It turns out that the signal of E3' is only detectable in samples with a Mg-content of $x \leq 0.5\%$, which are under tensile strain. It is absent in the relaxed polar (Mg,Zn)O samples with $x > 0.8\%$ and in the compressively strained non-polar a-ZnO film. The E3' defect shows a strong dependence on filling pulse duration and temperature, which is often associated with a defect that has a capture barrier for carrier capture. Auret \textit{et al.} investigated the carrier capture of E3' and concluded that E3' "is not a well-defined point defect but [...] it may have a somewhat extended nature onto which multiple charges can be captured, thus leading to a Coulomb barrier, somewhat like carrier capture onto a dislocation."\textsuperscript{57} Furthermore the authors found that E3' "is most prevalent in as-grown samples and samples that had been annealed in an oxygen atmosphere, suggesting that E3' may be related to oxygen incorporation in the lattice."\textsuperscript{57} The idea of E3' being an extended defect goes along with the fact that it is only incorporated in tensile strained films grown on an AZO buffer layer, which in turn introduces structural defects like dislocations in the film.

Regarding the positions of E1 and E3 in Fig. 4 in dependence of the Mg-content, it attracts attention that the peak maximum of E1 occurs almost at the same temperature independent of $x$, while a shift to higher temperatures is visible for the peak position of E3 in the (Mg,Zn)O samples with increasing $x$. That implies that the emission rate of E1 is independent of the Mg-content and that of E3 decreases with increasing Mg-content, which corresponds to an increase of the thermal activation energy of E3. The reason for that is the increase of the fundamental bandgap of (Mg,Zn)O with increasing $x$ and the relative energetic difference between E1 and E3, respectively, with respect to $E_c$. Figure 6 shows the change of the energetic position $\Delta E_t = E_{1,0} - E_{1,0,0}$ of the defects E1 and E3, respectively, versus $x$. In the case of E3, the data were obtained from LR-DLTS measurements (solid circles) and LDLTS measurements (open circles, Fig. 5) to distinguish the signature of E3 and E3' and avoid the determination of erroneous trap parameters. For E1, $E_t$ and $\sigma_n$ was obtained via the conventional DLTS measurement shown in Fig. 4. The change of the bandgap energy is given by the slope of $E_t(x)$ from Eq. (1) and indicated in Fig. 6 by the black solid line. The dashed

<table>
<thead>
<tr>
<th>$c$-(Mg,Zn)O</th>
<th>$\alpha$-ZnO</th>
</tr>
</thead>
<tbody>
<tr>
<td>$N_{\text{net}}$ ($10^{16}$ cm$^{-3}$)</td>
<td>6.7</td>
</tr>
<tr>
<td>$E_t$ (meV)</td>
<td>$\sigma_n$ ($10^{-15}$ cm$^2$)</td>
</tr>
<tr>
<td>T1</td>
<td>–</td>
</tr>
<tr>
<td>E64</td>
<td>–</td>
</tr>
<tr>
<td>E1</td>
<td>–</td>
</tr>
<tr>
<td>T2</td>
<td>–</td>
</tr>
<tr>
<td>E3 (LR)</td>
<td>–</td>
</tr>
<tr>
<td>E3 (L)</td>
<td>–</td>
</tr>
<tr>
<td>E3' (L)</td>
<td>–</td>
</tr>
<tr>
<td>E4</td>
<td>–</td>
</tr>
<tr>
<td>$\sigma_n$ ($10^{-15}$ cm$^2$)</td>
<td>0.3(4)</td>
</tr>
<tr>
<td>$N_t$ ($10^{14}$ cm$^{-3}$)</td>
<td>1.8</td>
</tr>
</tbody>
</table>

TABLE III. Trap parameters (thermal activation energy $E_t$, apparent capture cross-section $\sigma_n$) and defect concentrations $N_t$ obtained from DLTS, LR-DLTS (LR) and LDLTS (L) experiments.
lines represent the linear fits of ΔE_{t,E1} and ΔE_{t,E3} vs. x, respectively. While ΔE_{t} increases with x for the defect E3, this value remains almost constant for E1. This is equivalent to an increase of the energetic distance of E_{c} and E_{t} for E3, while this spacing remains stable for E1. The increasing bandgap energy splits into a shift of the conduction band-edge ΔE_{c} and valence band-edge ΔE_{v}. The ratio of ΔE_{c} to ΔE_{v} amounts^{26,71,72} ΔE_{c}/ΔE_{v} = 0.9/0.1 to 0.6/0.4. Rao et al. even report a negligible shift of the valence band^{73} (and therefore, ΔE_{g} = ΔE_{c}). According to the literature, the corresponding range of ΔE_{c} is shaded in Fig. 6. Hence, the energetic position of E3 is fixed in the band and does not change with respect to the vacuum level, the change of E_{c} increases the thermal activation energy of the deep-level. E1, in contrast, shows only a minor change of its energetic position with respect to the conduction band-edge—the defect-level follows E_{c}. The electronic wavefunctions of E1 are with that predominantly derived from the conduction band which is not the case for the E3 defect.

VI. E3 IN STRAINED (Mg, Zn)O THIN FILMS

As shown in Secs. III–V, the Mg-content influences the kind of strain as well as incorporation of defects in (Mg, Zn)O thin films grown on a AZO buffer layer. In the following, the response of E3 on the optical excitation with infrared (IR) light is investigated. Therefore, we compare the results of a tensile strained (Mg, Zn)O thin film with x = 0.5% and a similar sample with x = 2.2% being relaxed.

DLTS measurements under dark conditions and under optical excitation^{38,39} (DLOS) by the use of an IR laser were performed in a temperature range between 100 K and 200 K, respectively. We note that in the original work of Chantre et al. the method called DLOS^{38} considers only the initial derivation of the capacitance transient (t → 0) to obtain the

![Fig. 4. DLTS scans of polar (Mg,Zn)O thin films with 0 ≤ x ≤ 4.6% and a non-polar ZnO film for a rate-window of 500 Hz.](image)

![Fig. 5. LDLTS spectra of the a-ZnO and c-(Mg,Zn)O thin film samples, respectively, calculated from isothermal capacitance transients recorded at T = 180 K.](image)

![Fig. 6. Change in thermal activation energy ΔE_{t} of the deep-levels E1 (triangles) and E3 (circles), respectively, over Mg content x. The data were obtained from LDLTS (open symbols) and LR-DLTS experiments (solid symbols). The shaded area represents the change of the conduction band-edge ΔE_{c} reported in the literature.](image)
time constant $\tau$. In this work, $\tau$ is obtained by folding the photo-capacitance transient with a lock-in correlation function as it is, in principle, done in Lang’s conventional (thermal) DLTS$^{37}$ and as it was proposed by Brehme and Pickenhain.\textsuperscript{74} However, nowadays it has been adopted to call an experiment deep-level optical spectroscopy in which isothermal capacitance transients following a voltage pulse to a $pn$- or Schottky-diode are recorded as a function of the energy of monochromatic light being incident on the diode. This is done regardless of the method used for extracting the time constant. Photons used in the DLOS experiment having a wavelength of 1064 nm ($E_{\text{ph}} = 1.17\;\text{eV}$) are able to excite deep-levels with $E_t < 1.17\;\text{eV}$, hence it is possible to recharge $E_3$ and $E_{3}'$ but not the midgap level $T_4$,\textsuperscript{75} which has an activation energy above the photon energy $E_{\text{ph}}$. The results for the tensile strained (Mg,Zn)O thin film are shown in Figs. 7(a)–7(c) and data obtained from the relaxed sample are depicted in (d)–(f), respectively. In Fig. 7(a), the thermal emission of the deep defects $E_3$ and $E_{3}'$ can be seen as highlighted by the solid lines, which represent the calculated values of the emission rate using the trap parameters obtained from LDLTS measurements as listed in Table III. While the signatures of $E_3$ and $E_{3}'$ can be resolved for low temperatures the DLTS signals merge for higher temperatures and appear as one single peak.

Under optical excitation a DLTS maximum between 100 K and 140 K can be found at about 1 Hz, which is independent of temperature and disappears after thermal emission of the defects, i.e., between 160 K and 200 K. The whole signal shows an offset due to contributions of deeper defects with $E_i < E_{\text{ph}}$, such as $E_4$ and $E_5$.\textsuperscript{56,76}

In Fig. 7(c), DLTS scans using similar rate-windows, i.e., emission rates, are shown under dark condition (black line) and under optical excitation (grey line) for comparison as indicated by the horizontal line. Even though the concentrations of $E_3$ and $E_{3}'$ do not differ much, the step height occurring in the temperature scan between 120 K and 160 K with optical excitation can be assigned to $E_{3}'$ and not $E_3$. That means $E_{3}'$ can be emptied optically with an optical emission rate $\epsilon_o$ of approximately 1 Hz, whereas $E_3$ cannot be recharged. The measurement of the relaxed (Mg,Zn)O thin film with $x = 2.2\%$ is shown in Fig. 7(d) to 7(f). It was shown by the LDLTS experiments that $E_{3}'$ is not incorporated in such thin films. In contrast to the situation in the tensile strained sample, $E_3$ can be recharged with $\epsilon_o \approx 100\;\text{mHz}$, which we tentatively explain by means of an energy diagram as shown schematically in Fig. 8. From this depiction, it is evident that the interaction of $E_3$ with the conduction band $E_c$ depends on the strain state of the crystal and with that on the displacement of the $E_3$-parabola with respect to the reciprocal coordinate $Q$. While $E_3$ can be optical recharged in material being relaxed, the photo-ionization energy of $E_3$ is larger in the tensile strained crystals leading to a much lower optical emission rate. Due to the latter the transition is not detectable within the measurement range probed in the experiments. Of course the thermal activation energy of $E_3$ (as obtained from DLTS) is the same in both cases.

VII. SUMMARY

We investigated PLD grown (Mg,Zn)O thin films with Mg-contents between $0 \leq x \leq 4.6\%$ by means of PL, XRD, DLTS, LDLTS, LR-DLTS, and DLOS. Films were grown on a degenerately Al-doped ZnO buffer layer. Due to the Al doping, the $a$-lattice constant ($c$-lattice constant) is larger
The alloying of ZnO with MgO allows to predetermine the differences between samples with x = 0.5% and x = 0.8% that can be summarized as follows:

(i) a luminescence line Y2 is ascribed to the recombination of excitons bound to a line defect is only visible in (Mg,Zn)O thin films with x ≤ 0.5%. The feature is connected to tensile strain and absent in both the c-oriented (Mg,Zn)O films with x ≥ 0.8% and the non-polar a-oriented ZnO film.

(ii) defects in the upper third of the (Mg,Zn)O bandgap were investigated by means of DLTS. The polar samples with x ≤ 0.5% contain signatures of defects commonly observed in c-ZnO thin films on AZO, namely, T1, E64, E1, T2, and E3. T1, E64, and T2 are absent in relaxed c-oriented (Mg,Zn)O thin films with x ≥ 0.8% and non-polar a-oriented binary ZnO samples.

(iii) the defects E3 and E3’ were investigated by using LDTS and LR-DLTS. The structural defect E3’ is only detectable in the polar (Mg,Zn)O samples with x ≤ 0.5% and therefore connected to the in-plane tensile strain within these thin films. The concentration of E3 tends to increase in (Mg,Zn)O thin films with c-oriented (Mg,Zn)O thin films (Mater. Res. Soc. Symp. Proc., 2010), Vol. 1201.

(iv) optical excitation using an IR-laser shows that E3 can be recharged in a (Mg,Zn)O sample with x = 2.2%, while in a similar thin film with x = 0.5% (being under tensile strain) only E3’ responds to IR radiation. This indicates that the configuration of the E3 defect is sensitive to the strain state of the sample.

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